

INCH-POUND

MIL-M-38510/765A  
9 June 2005  
SUPERSEDING  
MIL-M-38510/765  
25 February 1991

MILITARY SPECIFICATION

MICROCIRCUITS, DIGITAL, ADVANCED CMOS,  
SHIFT REGISTERS, MONOLITHIC SILICON, POSITIVE LOGIC

Inactive for new and design after 9 August 1996

This specification is approved for use by all Departments  
and Agencies of the Department of Defense.

The requirements for acquiring the product herein shall consist of this specification sheet and MIL-PRF 38535

1. SCOPE

1.1 Scope. This specification covers the detail requirements for monolithic silicon, advanced CMOS, logic microcircuits. Two product assurance classes and a choice of case outlines, lead finishes, and radiation hardness assurance (RHA) are provided and are reflected in the complete Part or Identifying Number (PIN). For this product, the requirements of MIL-M-38510 have been superseded by MIL-PRF-38535 (see 6.3).

1.2 Part or identifying number (PIN). The PIN is in accordance with MIL-PRF-38535 and as specified herein.

1.2.1 Device types. The device types are as follows:

<u>Device type</u>	<u>Circuit</u>
01	To be included after dating
02	To be included after dating
03	To be included after dating
04	To be included after dating
05	To be included after dating
06	8-bit bidirectional universal shift/storage register with three-state outputs
07	To be included after dating

1.2.2 Device class. The device class is the product assurance level as defined in MIL-PRF-38535.

1.2.3 Case outlines. The case outlines are as designated in MIL-STD-1835 and as follows:

<u>Outline letter</u>	<u>Descriptive designator</u>	<u>Terminals</u>	<u>Package style</u>
R	GDIP1-T20 or CDIP2-T20	20	Dual-in-line
S	GDFP2-F20 or CDFP3-F20	20	Flat pack
2	CQCC1-N20	20	Square leadless-chip-carrier

Comments, suggestions, or questions on this document should be addressed to: Commander, Defense Supply Center Columbus, ATTN: DSCC-VAC, P.O. Box 3990, Columbus, OH 43218-3990, or email to [CMOS@dla.mil](mailto:CMOS@dla.mil). Since contact information can change, you may want to verify the currency of this address information using the ASSIST Online database at <http://assist.daps.dla.mil>.

1.3 Absolute maximum ratings. 1/ 2/

Supply voltage range ( $V_{CC}$ ).....	-0.5 V dc to +6.0 V dc
DC input voltage range ( $V_{IN}$ ).....	-0.5 V dc to $V_{CC} + 0.5$ V dc
DC output voltage range ( $V_{OUT}$ ).....	-0.5 V dc to $V_{CC} + 0.5$ V dc
Clamp diode current ( $I_{IK}, I_{OK}$ ).....	$\pm 20$ mA
DC output current ( $I_{OUT}$ ).....	$\pm 50$ mA
DC $V_{CC}$ or GND current ( $I_{CC}, I_{GND}$ ).....	$\pm 100$ mA
Storage temperature range ( $T_{STG}$ ).....	-65°C to +150°C
Maximum power dissipation ( $P_D$ ).....	300 mW
Lead temperature (soldering, 10 seconds).....	+300°C
Thermal resistance, junction-to-case ( $\theta_{JC}$ ).....	See MIL-STD-1835
Junction temperature ( $T_J$ ).....	+175°C
Case operating temperature range ( $T_C$ ).....	-55°C to +125°C

1.4 Recommended operating conditions. 2/ 3/ 4/

Supply voltage range ( $V_{CC}$ ).....	+3.0 V dc to +5.5 V dc
Input voltage range ( $V_{IN}$ ).....	+0.0 V dc to $V_{CC}$
Output voltage range ( $V_{OUT}$ ).....	+0.0 V dc to $V_{CC}$
Case operating temperature range ( $T_C$ ).....	-55°C to +125°C
Maximum low level input voltage ( $V_{IL}$ ).....	0.90 V dc at $V_{CC} = 3.0$ V dc 1.35 V dc at $V_{CC} = 4.5$ V dc 1.65 V dc at $V_{CC} = 5.5$ V dc
Minimum high level input voltage ( $V_{IH}$ ).....	2.10 V dc at $V_{CC} = 3.0$ V dc 3.15 V dc at $V_{CC} = 4.5$ V dc 3.85 V dc at $V_{CC} = 5.5$ V dc
Input rise and fall rate ( $t_r, t_f$ ) maximum: $V_{CC} = 3.6$ V, $V_{CC} = 5.5$ V.....	8 ns/V
Minimum setup time, high or low, Sn to CLK ( $t_{s1}$ ): $V_{CC} = 3.0$ V; $T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	<u>Device type 06</u> 8.5 ns
$T_C = +125^\circ\text{C}$ .....	9.5 ns
$V_{CC} = 4.5$ V; $T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	6.0 ns
$T_C = +125^\circ\text{C}$ .....	7.0 ns
Minimum hold time, high or low, Sn to CLK ( $t_{h1}$ ): $V_{CC} = 3.0$ V; $T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	<u>Device type 06</u> 2.0 ns
$T_C = +125^\circ\text{C}$ .....	2.0 ns
$V_{CC} = 4.5$ V; $T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	2.0 ns
$T_C = +125^\circ\text{C}$ .....	2.5 ns
Minimum setup time, high or low, I/On to CLK ( $t_{s2}$ ): $V_{CC} = 3.0$ V; $T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	<u>Device type 06</u> 5.5 ns
$T_C = +125^\circ\text{C}$ .....	6.0 ns
$V_{CC} = 4.5$ V; $T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	3.5 ns
$T_C = +125^\circ\text{C}$ .....	4.0 ns
Minimum hold time, high or low, I/On to CLK ( $t_{h2}$ ): $V_{CC} = 3.0$ V; $T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	<u>Device type 06</u> 1.5 ns
$T_C = +125^\circ\text{C}$ .....	1.5 ns
$V_{CC} = 4.5$ V; $T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	2.0 ns
$T_C = +125^\circ\text{C}$ .....	2.0 ns

See footnotes on next page.

1.4 Recommended operating conditions – Continued. 2/ 3/ 4/

Minimum setup time, high or low, DS0 or DS7 to CLK ( $t_{s3}$ ):	<u>Device type 06</u>
$V_{CC} = 3.0\text{ V}; T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	6.5 ns
$T_C = +125^\circ\text{C}$ .....	7.5 ns
$V_{CC} = 4.5\text{ V}; T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	4.0 ns
$T_C = +125^\circ\text{C}$ .....	5.0 ns
Minimum hold time, high or low, DS0 or DS7 to CLK ( $t_{h3}$ ):	<u>Device type 06</u>
$V_{CC} = 3.0\text{ V}; T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	1.0 ns
$T_C = +125^\circ\text{C}$ .....	1.5 ns
$V_{CC} = 4.5\text{ V}; T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	1.5 ns
$T_C = +125^\circ\text{C}$ .....	1.5 ns
Minimum CLK pulse width, high or low ( $t_{w1}$ ):	<u>Device type 06</u>
$V_{CC} = 3.0\text{ V}; T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	5.0 ns
$T_C = +125^\circ\text{C}$ .....	5.5 ns
$V_{CC} = 4.5\text{ V}; T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	5.0 ns
$T_C = +125^\circ\text{C}$ .....	5.0 ns
Minimum $\overline{\text{MR}}$ pulse width, low ( $t_{w2}$ ):	<u>Device type 06</u>
$V_{CC} = 3.0\text{ V}; T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	5.0 ns
$T_C = +125^\circ\text{C}$ .....	5.5 ns
$V_{CC} = 4.5\text{ V}; T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	5.0 ns
$T_C = +125^\circ\text{C}$ .....	5.0 ns
Minimum recovery time, $\overline{\text{MR}}$ to CLK ( $t_{rec}$ ):	<u>Device type 06</u>
$V_{CC} = 3.0\text{ V}; T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	2.5 ns
$T_C = +125^\circ\text{C}$ .....	2.5 ns
$V_{CC} = 4.5\text{ V}; T_C = +25^\circ\text{C}, -55^\circ\text{C}$ .....	2.5 ns
$T_C = +125^\circ\text{C}$ .....	2.5 ns

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- 1/ Stresses above the absolute maximum rating may cause permanent damage to the device. Extended operation at the maximum levels may degrade performance and affect reliability. The maximum junction temperature may be exceeded for allowable short duration burn-in screening conditions in accordance with MIL-PRF-38535.
- 2/ Unless otherwise noted, all voltages are referenced to GND.
- 3/ Operation from 2.0 V dc to 3.0 V dc is provided for compatibility with data retention and battery back-up systems. Data retention implies no input transitions and no stored data loss with the following conditions:  $V_{IH} \geq 70$  percent of  $V_{CC}$ ,  $V_{IL} \leq 30$  percent of  $V_{CC}$ ,  $V_{OH} \geq 70$  percent of  $V_{CC}$  at  $-20\ \mu\text{A}$ ,  $V_{OL} \leq 30$  percent of  $V_{CC}$  at  $20\ \mu\text{A}$ .
- 4/ Unless otherwise specified, the values listed above shall apply over the full  $V_{CC}$  and  $T_C$  recommended operating range.

## 2. APPLICABLE DOCUMENTS

2.1 General. The documents listed in this section are specified in sections 3, 4, or 5 of this specification. This section does not include documents cited in other sections of this specification or recommended for additional information or as examples. While every effort has been made to ensure the completeness of this list, document users are cautioned that they must meet all specified requirements of documents cited in sections 3, 4, or 5 of this specification, whether or not they are listed.

### 2.2 Government documents.

2.2.1 Specifications and Standards. The following specifications and standards form a part of this specification to the extent specified herein. Unless otherwise specified, the issues of these documents are those cited in the solicitation or contract.

#### DEPARTMENT OF DEFENSE SPECIFICATION

MIL-PRF-38535 - Integrated Circuits (Microcircuits) Manufacturing, General Specification for.

#### DEPARTMENT OF DEFENSE STANDARDS

MIL-STD-883 - Test Method Standard Microcircuits.  
MIL-STD-1835 - Interface Standard Electronic Component Case Outlines.

(Copies of these documents are available online at <http://assist.daps.dla.mil/quicksearch/> or <http://assist.daps.dla.mil> or from the Standardization Document Order Desk, 700 Robbins Avenue, Building 4D, Philadelphia, PA 19111-5094.)

2.3 Non-Government publications. The following document(s) form a part of this document to the extent specified herein. Unless otherwise specified, the issues of these documents are those cited in the solicitation or contract.

#### ELECTRONIC INDUSTRIES ALLIANCE (EIA)

EIA/JEDEC Standard No. 78 - IC Latch-Up Test

JEDEC Standard No. 20 - Standard for Description of 54/74ACXXXXX and 54/74ACTXXXXX Advanced High-Speed CMOS Devices

(Copies of these documents are available on line at <http://www.jedec.org> or from Electronic Industries Alliance, 2500 Wilson Boulevard, Arlington, VA 22201-3834).

2.4 Order of precedence. In the event of a conflict between the text of this document and the references cited herein, the text of this document takes precedence. Nothing in this document, however, supersedes applicable laws and regulations unless a specific exemption has been obtained.

## 3. REQUIREMENTS

3.1 Qualification. Microcircuits furnished under this specification shall be products that are manufactured by a manufacturer authorized by the qualifying activity for listing on the applicable qualified manufacturers list before contract award (see 4.3 and 6.4).

3.2 Item requirements. The individual item requirements shall be in accordance with MIL-PRF-38535 and as specified herein or as modified in the device manufacturer's Quality Management (QM) plan. The modification in the QM plan shall not affect the form, fit, or function as described herein.

3.3 Design, construction, and physical dimensions. The design, construction, and physical dimensions shall be as specified in MIL-PRF-38535 and herein.

3.3.1 Terminal connections. The terminal connections shall be as specified on figure 1.

3.3.2 Truth tables. The truth tables shall be as specified on figure 2.

3.3.3 Switching time waveforms and test circuit. The switching time waveforms and test circuit shall be as specified on figure 3.

3.3.4 Schematic circuits. The schematic circuits shall be maintained by the manufacturer and made available to the qualifying activity or preparing activity upon request.

3.3.5 Case outlines. The case outlines shall be as specified in 1.2.3 herein.

3.4 Lead material and finish. The lead material and finish shall be in accordance with MIL-PRF-38535 (see 6.6).

3.5 Electrical performance characteristics and post irradiation end-point electrical parameter limits. Unless otherwise specified, the electrical performance characteristics and postirradiation end-point electrical parameter limits are as specified in table I and apply over the case operating temperature range specified. Test conditions for these specified characteristics and limits are as specified in table I.

3.6 Electrical test requirements. The electrical test requirements for each device class shall be the subgroups specified in table II. The electrical tests for each subgroup are described in table I. Radiation hardness assurance level M, D, P, L, and R (see MIL-PRF-38535) in table I are postirradiation end-point electrical parameters.

3.7 Marking. Marking shall be in accordance with MIL-PRF-38535.

3.7.1 Radiation hardness assurance identifier. The radiation hardness assurance identifier shall be in accordance with MIL-PRF-38535 and herein (see 3.6).

3.8 Microcircuit group assignment. The devices covered by this specification shall be in microcircuit group number 40 (see MIL-PRF-38535, appendix A).

Table I. Electrical performance characteristics and post irradiation end-point electrical parameter limits.

Test	Symbol	Test conditions, unless otherwise specified <u>1/</u>	Device type <u>2/</u>	V <sub>CC</sub>	Group A subgroups (test method)	-55°C/+25°C limits		+125°C limits		Unit
						Min	Max	Min <u>3/</u>	Max <u>3/</u>	
High level output voltage	V <sub>OH1</sub> <u>4/</u>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 2.10 V V <sub>IL</sub> = 0.90 V I <sub>OH</sub> = -50 μA	All	3.0 V	1,2,3 (3006)	2.9		2.9		V
	V <sub>OH2</sub> <u>4/</u>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 3.15 V V <sub>IL</sub> = 1.35 V I <sub>OH</sub> = -50 μA	All	4.5 V		4.4		4.4		
	V <sub>OH3</sub>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 3.85 V V <sub>IL</sub> = 1.65 V I <sub>OH</sub> = -50 μA	All	5.5V 06		5.4		5.4		
	V <sub>OH4</sub> <u>4/</u>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 2.10 V V <sub>IL</sub> = 0.90 V I <sub>OH</sub> = -4.0 mA	All		3.0 V	1,2,3 (3006)	2.4		2.4	
	V <sub>OH5</sub>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 3.15 V V <sub>IL</sub> = 1.35 V I <sub>OH</sub> = -24 mA	M,D,P, L,R <u>5/</u>	06	4.5 V		1 (3006)	3.7		
	V <sub>OH6</sub> <u>4/</u>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 3.85 V V <sub>IL</sub> = 1.65 V I <sub>OH</sub> = -24 mA	All	5.5 V	1,2,3 (3006)	4.7		4.7		
	V <sub>OH7</sub> <u>6/</u>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 3.85 V V <sub>IL</sub> = 1.65 V I <sub>OH</sub> = -50 mA	M,D,P, L,R <u>5/</u>	06	5.5 V	1 (3006)	3.85		3.85	
Low level output voltage	V <sub>OL1</sub> <u>4/</u>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 2.10 V V <sub>IL</sub> = 0.90 V I <sub>OL</sub> = 50 μA	All	3.0 V	1,2,3 (3007)		0.1		0.1	
	V <sub>OL2</sub> <u>4/</u>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 3.15 V V <sub>IL</sub> = 1.35 V I <sub>OL</sub> = 50 μA	All	4.5 V			0.1		0.1	
	V <sub>OL3</sub>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 3.85 V V <sub>IL</sub> = 1.65 V I <sub>OL</sub> = 50 μA	All	5.5 V 06			0.1		0.1	
		M,D,P, L,R <u>5/</u>	1 (3007)			0.1				

See footnotes at end of table.

TABLE I. Electrical performance characteristics and postirradiation end-point electrical parameter limits – Continued.

Test	Symbol	Test conditions, unless otherwise specified <u>1/</u>	Device type <u>2/</u>	V <sub>CC</sub>	Group A subgroups (test method)	-55°C/+25°C limits		+125°C limits		Unit
						Min	Max	Min <u>3/</u>	Max <u>3/</u>	
Low level output voltage	V <sub>OL4</sub> <u>4/</u>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 2.10 V V <sub>IL</sub> = 0.90 V I <sub>OL</sub> = 12 mA	All	3.0 V	1,2,3 (3007)		0.4		0.5	V
	V <sub>OL5</sub>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 3.15 V V <sub>IL</sub> = 1.35 V I <sub>OL</sub> = 24 mA	All M,D,P, L,R <u>5/</u>	4.5 V	1 (3007)		0.4		0.5	
	V <sub>OL6</sub> <u>4/</u>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 3.85 V V <sub>IL</sub> = 1.65 V I <sub>OL</sub> = 24 mA	All	5.5 V	1,2,3 (3007)		0.4		0.5	
	V <sub>OL7</sub> <u>6/</u>	V <sub>IN</sub> = V <sub>IH</sub> or V <sub>IL</sub> V <sub>IH</sub> = 3.85 V V <sub>IL</sub> = 1.65 V I <sub>OL</sub> = 50 mA	All M,D,P, L,R <u>5/</u>	5.5 V	1 (3007)		1.65 1.65		1.65	
Positive input clamp voltage	V <sub>IC+</sub> <u>7/</u>	I <sub>IN</sub> = 1 mA	All	GND	1 (3022)	0.4	1.5			
			M,D,P, L,R <u>5/</u>	06	1 (3022)	0.4	1.5			
Negative input clamp voltage	V <sub>IC-</sub> <u>7/</u>	I <sub>IN</sub> = -1 mA	All	Open	1 (3022)	-0.4	-1.5			
			M,D,P, L,R <u>5/</u>	06	1 (3022)	-0.4	-1.5			
Input current low (excluding I/O ports)	I <sub>IL</sub> <u>7/</u>	V <sub>IN</sub> = GND	All	5.5 V	1,2 (3009)		-0.1		-1.0	μA
			M,D,P, L,R <u>5/</u>	06	1 (3009)		-0.1			
Input current high (excluding I/O ports)	I <sub>IH</sub> <u>7/</u>	V <sub>IN</sub> = V <sub>CC</sub>	All	5.5 V	1,2 (3009)		0.1		1.0	
			M,D,P, L,R <u>5/</u>	06	1 (3009)		0.1			

See footnotes at end of table.

TABLE I. Electrical performance characteristics and postirradiation end-point electrical parameter limits – Continued.

Test	Symbol	Test conditions, unless otherwise specified <u>1/</u>	Device type <u>2/</u>	V <sub>CC</sub>	Group A subgroups (test method)	-55°C/+25°C limits		+125°C limits		Unit
						Min	Max	Min <u>3/</u>	Max <u>3/</u>	
Supply current quiescent	I <sub>CC</sub> <u>7/</u>	V <sub>IN</sub> = V <sub>CC</sub> or GND	All	5.5 V	1,2 (3005)		2		10	μA
			06		1 (3005)		25			
							200			
							700			
Three-state output leakage current low	I <sub>OZL</sub> <u>7/</u>	V <sub>OUT</sub> = GND <u>8/</u>	All	5.5 V	1,2,3 (3005)		-0.6		-11.0	μA
			06		1 (3005)		-25			
Three-state output leakage current high	I <sub>OZH</sub> <u>7/</u>	V <sub>OUT</sub> = V <sub>CC</sub> <u>8/</u>	All	5.5 V	1,2,3 (3005)		+0.6		+11.0	μA
			06		1 (3005)		+25			
Input/output capacitance	C <sub>I/O</sub>	See 4.4.1c T <sub>C</sub> = 25°C <u>9/</u>	All	5.5 V	4 (3012)		15			pF
Input capacitance	C <sub>IN</sub>	See 4.4.1c T <sub>C</sub> = 25°C	All	GND	4 (3012)		10			
Power dissipation capacitance	C <sub>PD</sub>	See 4.4.1c T <sub>C</sub> = 25°C <u>10/</u>	All		4		250			
Latch-up input/output over-voltage <u>11/</u>	I <sub>CC</sub> (O/V1)	t <sub>w</sub> ≥ 100 μs t <sub>cool</sub> ≥ t <sub>w</sub> 5 μs ≤ t <sub>r</sub> ≤ 5 ms 5 μs ≤ t <sub>f</sub> ≤ 5 ms V <sub>test</sub> = 6.0 V V <sub>CCQ</sub> = 5.5 V V <sub>over</sub> = 10.5 V	All	5.5 V	2				200	mA
Latch-up input/output positive over-current <u>11/</u>	I <sub>CC</sub> (O/I1+)	t <sub>w</sub> ≥ 100 μs t <sub>cool</sub> ≥ t <sub>w</sub> 5 μs ≤ t <sub>r</sub> ≤ 5 ms 5 μs ≤ t <sub>f</sub> ≤ 5 ms V <sub>test</sub> = 6.0 V V <sub>CCQ</sub> = 5.5 V I <sub>trigger</sub> = +120 mA	All	5.5 V	2				200	mA
Latch-up input/output negative over-current <u>11/</u>	I <sub>CC</sub> (O/I1-)	t <sub>w</sub> ≥ 100 μs t <sub>cool</sub> ≥ t <sub>w</sub> 5 μs ≤ t <sub>r</sub> ≤ 5 ms 5 μs ≤ t <sub>f</sub> ≤ 5 ms V <sub>test</sub> = 6.0 V V <sub>CCQ</sub> = 5.5 V I <sub>trigger</sub> = -120 mA	All	5.5 V	2				200	mA

See footnotes at end of table.

TABLE I. Electrical performance characteristics and postirradiation end-point electrical parameter limits – Continued.

Test	Symbol	Test conditions, unless otherwise specified <u>1/</u>	Device type <u>2/</u>	V <sub>CC</sub>	Group A subgroups (test method)	-55°C/+25°C limits		+125°C limits		Unit	
						Min	Max	Min <u>3/</u>	Max <u>3/</u>		
Latch-up input/output over-voltage <u>11/</u>	I <sub>CC</sub> (O/V2)	t <sub>w</sub> ≥ 100 μs t <sub>cool</sub> ≥ t <sub>w</sub> 5 μs ≤ t <sub>r</sub> ≤ 5 ms 5 μs ≤ t <sub>f</sub> ≤ 5 ms V <sub>test</sub> = 6.0 V V <sub>CCQ</sub> = 5.5 V V <sub>over</sub> = 9.0 V	All	5.5 V	2				100	mA	
Truth table test	<u>12/</u>	V <sub>IL</sub> = .45 V V <sub>IH</sub> = 2.5 V Verify output V <sub>O</sub> <u>5/</u>	M,D,P, L,R	06	3.0 V	7 (3014)	L	H			
		V <sub>IL</sub> = .6 V V <sub>IH</sub> = 3.7 V Verify output V <sub>O</sub>		All	4.5 V	7,8 (3014)	L	H	L	H	
Maximum CLK frequency	f <sub>MAX</sub>	C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See 4.4.1f	All	3.0 V	9,10,11	90		70		MHz	
				4.5 V		130		80			
Propagation delay time, CLK to I/On	t <sub>PHL1</sub> , t <sub>PLH1</sub>	C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 <u>13/ 14/</u>	M,D,P, L,R <u>5/</u>	All	3.0 V	9,10,11 (3003)	1.0	23.0	1.0	26.5	ns
				06		9 (3003)	1.0	23.0			
		C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 <u>13/ 14/</u>	M,D,P, L,R <u>5/</u>	All	4.5 V	9,10,11 (3003)	1.0	16.0	1.0	18.5	ns
				06		9 (3003)	1.0	16.0			
Propagation delay time, CLK to Q0, CLK to Q7	t <sub>PHL2</sub> , t <sub>PLH2</sub>	C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 <u>13/ 14/</u>	M,D,P, L,R <u>5/</u>	All	3.0 V	9,10,11 (3003)	1.0	21.5	1.0	26.5	ns
				06		9 (3003)	1.0	21.5			
		C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 <u>13/ 14/</u>	M,D,P, L,R <u>5/</u>	All	4.5 V	9,10,11 (3003)	1.0	14.5	1.0	18.0	ns
				06		9 (3003)	1.0	14.5			

See footnotes at end of table.

TABLE I. Electrical performance characteristics and postirradiation end-point electrical parameter limits – Continued.

Test	Symbol	Test conditions, unless otherwise specified <u>1/</u>	Device type <u>2/</u>	V <sub>CC</sub>	Group A subgroups (test method)	-55°C/+25°C limits		+125°C limits		Unit
						Min	Max	Min <u>3/</u>	Max <u>3/</u>	
Propagation delay time, MR to Q0 or MR to Q7	t <sub>PHL3</sub>	C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 <u>13/ 14/</u>	All	3.0 V	9,10,11 (3003)	1.0	22.5	1.0	27.0	ns
			M,D,P, L,R <u>5/</u> 06		9 (3003)	1.0	22.5			
		C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 <u>13/ 14/</u>	All	4.5 V	9,10,11 (3003)	1.0	15.5	1.0	18.5	ns
			M,D,P, L,R <u>5/</u> 06		9 (3003)	1.0	15.5			
Propagation delay time, MR to I/On	t <sub>PHL4</sub>	C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 <u>13/ 14/</u>	All	3.0 V	9,10,11 (3003)	1.0	21.5	1.0	26.5	ns
			M,D,P, L,R <u>5/</u> 06		9 (3003)	1.0	21.5			
		C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 <u>13/ 14/</u>	All	4.5 V	9,10,11 (3003)	1.0	15.0	1.0	18.0	ns
			M,D,P, L,R <u>5/</u> 06		9 (3003)	1.0	15.0			
Output enable time, OEn to I/On	t <sub>PZH1</sub> , t <sub>PZL1</sub>	C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 <u>13/ 14/</u>	All	3.0 V	9,10,11 (3003)	1.0	19.5	1.0	23.5	ns
			M,D,P, L,R <u>5/</u> 06		9 (3003)	1.0	19.5			
		C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 <u>13/ 14/</u>	All	4.5 V	9,10,11 (3003)	1.0	13.0	1.0	16.0	ns
			M,D,P, L,R <u>5/</u> 06		9 (3003)	1.0	13.0			

See footnotes at end of table.

TABLE I. Electrical performance characteristics and postirradiation end-point electrical parameter limits – Continued.

Test	Symbol	Test conditions, unless otherwise specified <u>1/</u>	Device type <u>2/</u>	V <sub>CC</sub>	Group A subgroups (test method)	-55°C/+25°C limits		+125°C limits		Unit
						Min	Max	Min <u>3/</u>	Max <u>3/</u>	
Output enable time, S0 = S1 = H to I/On	t <sub>PZH2</sub> , t <sub>PZL2</sub>	C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 4/ <u>14/</u>	All	3.0 V	9,10,11 (3003)	1.0	19.5	1.0	23.5	ns
			M,D,P, L,R <u>5/</u>		06	9 (3003)	1.0	19.5		
		C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 4/ <u>14/</u>	All	4.5 V	9,10,11 (3003)	1.0	13.0	1.0	16.0	ns
			M,D,P, L,R <u>5/</u>		06	9 (3003)	1.0	13.0		
Output disable time, OEn to I/On	t <sub>PHZ1</sub> , t <sub>PLZ1</sub>	C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 13/ <u>14/</u>	All	3.0 V	9,10,11 (3003)	1.0	19.0	1.0	22.5	ns
			M,D,P, L,R <u>5/</u>		06	9 (3003)	1.0	19.0		
		C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 13/ <u>14/</u>	All	4.5 V	9,10,11 (3003)	1.0	14.0	1.0	17.0	ns
			M,D,P, L,R <u>5/</u>		06	9 (3003)	1.0	14.0		
Output disable time, S0 = S1 = H to I/On	t <sub>PHZ2</sub> , t <sub>PLZ2</sub>	C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 4/ <u>14/</u>	All	3.0 V	9,10,11 (3003)	1.0	19.0	1.0	22.5	ns
			M,D,P, L,R <u>5/</u>		06	9 (3003)	1.0	19.0		
		C <sub>L</sub> = 50 pF R <sub>L</sub> = 500Ω See figure 3 4/ <u>14/</u>	All	4.5 V	9,10,11 (3003)	1.0	14.0	1.0	17.0	ns
			M,D,P, L,R <u>5/</u>		06	9 (3003)	1.0	14.0		

1/ Each input/output, as applicable, shall be tested at the specified temperature for the specified limits. Output terminals not designated shall be high level logic, low level logic, or open, except as follows:

- a. V<sub>IC</sub> (pos) tests, the GND terminal can be open. T<sub>C</sub> = +25°C.
- b. V<sub>IC</sub> (neg) tests, the V<sub>CC</sub> terminal shall be open. T<sub>C</sub> = +25°C.
- c. All I<sub>CC</sub> tests, the output terminal shall be open. When performing these tests, the current meter shall be placed in the circuit such that all current flows through the meter.

2/ The word “All” in the device type column means non-RHA limits for all devices types. M, D, P, L, and R in the conditions column specify the postirradiation limits for those device types specified in the device type column.

3/ RHA samples do not have to be tested at T<sub>A</sub> = +125°C prior to irradiation.

TABLE I. Electrical performance characteristics and postirradiation end-point electrical parameter limits – Continued.

- 4/ This parameter is provided as design information only.
- 5/ Postirradiation electrical measurements for any RHA level shall be performed at  $T_A = +25^\circ\text{C}$ . Limits shown are guaranteed at  $T_A = +25^\circ\text{C} \pm 5^\circ\text{C}$ .
- 6/ Transmission driving tests are performed at  $V_{CC} = 5.5\text{ V}$  dc with a 2 ms duration maximum.
- 7/ Not tested at  $-55^\circ\text{C}$ .
- 8/ Three-state output conditions are required. For  $I_{OZL}$ , set outputs to high state. For  $I_{OZH}$ , set outputs to low state. Set input pins to  $V_{IL} = V_{IL(\text{MAX})}$  and  $V_{IH} = V_{IH(\text{MIN})}$ , as required.  $I_{OZL}$  and  $I_{OZH}$  shall include  $I_{IL}$  and  $I_{IH}$ , respectively.
- 9/ Set output enable control pins to  $V_{CC}$  or GND, as applicable, to disable the outputs.
- 10/ Power dissipation capacitance ( $C_{PD}$ ) determines the no load dynamic power consumption,  $P_D = (C_{PD} + C_L)(V_{CC} \times V_{CC})f + (I_{CC} \times V_{CC})$  and the dynamic current consumption,  $I_S = (C_{PD} + C_L)V_{CC}f + I_{CC}$ . For both  $C_{PD}$  and  $I_S$ ,  $f$  is the frequency of the input signal.
- 11/ See EIA/JEDEC STD. No. 78 for electrically induced latch-up test methods and procedures. The values listed for  $I_{\text{trigger}}$  and  $V_{\text{over}}$  are to be accurate within  $\pm 5$  percent.
- 12/ Tests shall be performed in sequence, attributes data only. Functional tests shall include the truth tables and other logic patterns used for fault detection. Functional tests shall be performed in sequence as approved by the qualifying activity on qualified devices.  $H \geq 2.5\text{ V}$ ,  $L \leq 2.5\text{ V}$ ; high inputs = 3.7 V and low inputs = 0.6 V for  $V_{CC} = 4.5\text{ V}$  and  $H \geq 1.5\text{ V}$ ,  $L \leq 1.5\text{ V}$ ; high inputs = 2.5 V and low inputs = 0.45 V for  $V_{CC} = 3.0\text{ V}$ . Tests at  $V_{CC} = 3.0\text{ V}$  are for RHA specified devices only ( $T_A = +25^\circ\text{C} \pm 5^\circ\text{C}$ ).
- 13/ Device are tested at  $V_{CC} = 3.0\text{ V}$  and  $V_{CC} = 4.5\text{ V}$  at  $T_C = +125^\circ\text{C}$  for sample testing and at  $V_{CC} = 3.0\text{ V}$  and  $V_{CC} = 4.5\text{ V}$  at  $T_C = +25^\circ\text{C}$  for screening. Other voltages of  $V_{CC}$  and temperatures are guaranteed, if not tested. See 4.4.1d.
- 14/ AC limits at  $V_{CC} = 5.5\text{ V}$  are equal to the limits at  $V_{CC} = 4.5\text{ V}$  and guaranteed by testing at  $V_{CC} = 4.5\text{ V}$ . Minimum ac limits for  $V_{CC} = 5.5\text{ V}$  are 1.0 ns and guaranteed by guardbanding the  $V_{CC} = 4.5\text{ V}$  minimum limits to 1.5 ns. For propagation delay tests, all paths must be tested.

Device type	06
Case outlines	R, S, 2
Terminal numbers	Terminal symbols
1	$\overline{S0}$
2	$\overline{OE1}$
3	$\overline{OE2}$
4	I/O6
5	I/O4
6	I/O2
7	I/O0
8	$\overline{Q0}$
9	$\overline{MR}$
10	GND
11	DS0
12	CLK
13	I/O1
14	I/O3
15	I/O5
16	I/O7
17	Q7
18	DS7
19	S1
20	V <sub>cc</sub>

FIGURE 1. Terminal connections.

Device type 06

Asynchronous operations (CP, DS0, DS7 = X;  $\overline{OE1}$ ,  $\overline{OE2}$  = L, S0 and S1 shall not simultaneously = H).

Mode	Inputs			Inputs/outputs				Outputs	
	$\overline{MR}$	S0	S1	I/O0	I/O1	---	I/O7	Q0	Q7
Reset	L	X	X	L	L	---	L	L	L
Hold	H	L	L	N/C	N/C	---	N/C	N/C	N/C

Synchronous operations ( $\overline{MR}$  = H,  $\overline{OE1}$ ,  $\overline{OE2}$  = L)

Mode	Inputs					Inputs/outputs 1/ 2/				Outputs 2/	
	CP	S0	S1	DS0	DS7	I/O0	I/O1	---	I/O7	Q0	Q7
Load	↑	H	H	X	X	Z	Z	---	Z	D0	D7
Shift right	↑	L	H	L	X	L	D0	---	D6	L	D6
	↑	L	H	H	X	H	D0	---	D6	H	D6
Shift left	↑	H	L	X	L	D1	D2	---	L	D1	L
	↑	H	L	X	H	D1	D2	---	H	D1	H

1/ When S0 = S1 = H simultaneously, outputs I/On are in a high impedance state (Z).

2/ Shown are the state of the outputs after the low-to-high clock transition. D0 to D7 represent the data that was stored in the eight flip-flops, Q0 to Q7, prior to the clock transition.

High Z conditions

Mode	Inputs		Inputs/outputs 1/				Outputs	
	$\overline{OE1}$	$\overline{OE2}$	I/O0	I/O1	---	I/O7	Q0	Q7
High Z	H	X	Z	Z	---	Z	<u>2/</u>	<u>2/</u>
	X	H	Z	Z	---	Z	<u>2/</u>	<u>2/</u>

1/ When S0 = S1 = H simultaneously, outputs I/On are in a high impedance state (Z).

2/ During the high Z condition, shift, hold, load, and reset operations can still occur. Outputs Q0 and Q7 are affected accordingly.

H = High voltage level

L = Low voltage level

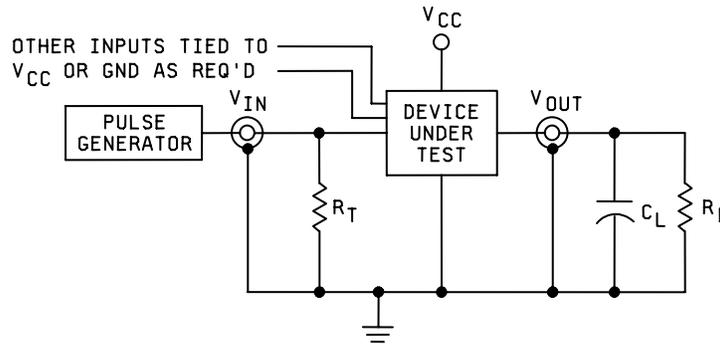
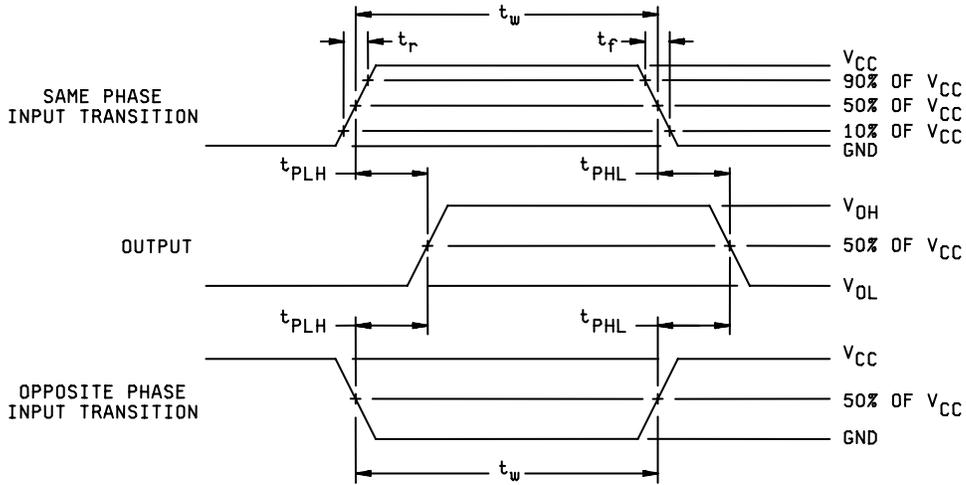
X = Irrelevant

Z = High impedance

↑ = Low-to-high clock transition

N/C = No change

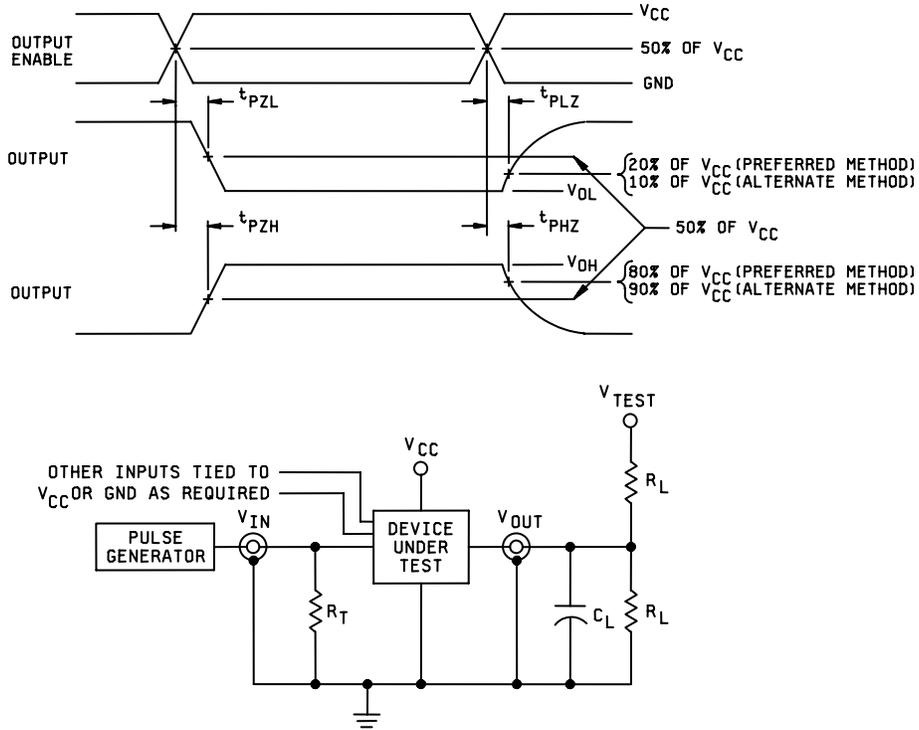
FIGURE 2. Truth tables.



NOTES:

1.  $C_L = 50\text{pF}$  or equivalent (includes test jig and probe capacitance).
2.  $R_L = 500\Omega$  or equivalent.
3.  $R_T = 50\Omega$  or equivalent.
4. Input signal from pulse generator:  $V_{IN} = 0.0\text{ V to } V_{CC}$ ;  $\text{PRR} \leq 10\text{ MHz}$ ; duty cycle = 50 percent,  $t_r \leq 3.0\text{ ns}$ ;  $t_f \leq 3.0\text{ ns}$ ;  $t_r$  and  $t_f$  shall be measured from 10% of  $V_{CC}$  to 90% of  $V_{CC}$  and from 90% of  $V_{CC}$  to 10% of  $V_{CC}$ , respectively.

FIGURE 3. Switching time waveforms and test circuits.



NOTES:

1. PREFERRED METHOD:  
 When measuring  $t_{PHZ}$  or  $t_{PZH}$ ;  $V_{TEST} = GND$   
 When measuring  $t_{PLZ}$  or  $t_{PZL}$ ;  $V_{TEST} = 2(V_{CC})$
2. ALTERNATE METHOD:  
 When measuring  $t_{PHZ}$  or  $t_{PZH}$ ;  $V_{TEST} = OPEN$   
 When measuring  $t_{PLZ}$  or  $t_{PZL}$ ;  $V_{TEST} = 2(V_{CC})$
3.  $C_L = 50pF$  or equivalent (includes test jig and probe capacitance).
4.  $R_L = 500\Omega$  or equivalent.
5.  $R_T = 50\Omega$  or equivalent.
6. Input signal from pulse generator:  $V_{IN} = 0.0 V$  to  $V_{CC}$ ;  $PRR \leq 10 MHz$ ; duty cycle = 50 percent,  $t_r \leq 3.0 ns$ ;  $t_f \leq 3.0 ns$ ;  $t_r$  and  $t_f$  shall be measured from 10% of  $V_{CC}$  to 90% of  $V_{CC}$  and from 90% of  $V_{CC}$  to 10% of  $V_{CC}$ , respectively.

FIGURE 3. Switching time waveforms and test circuits – Continued.

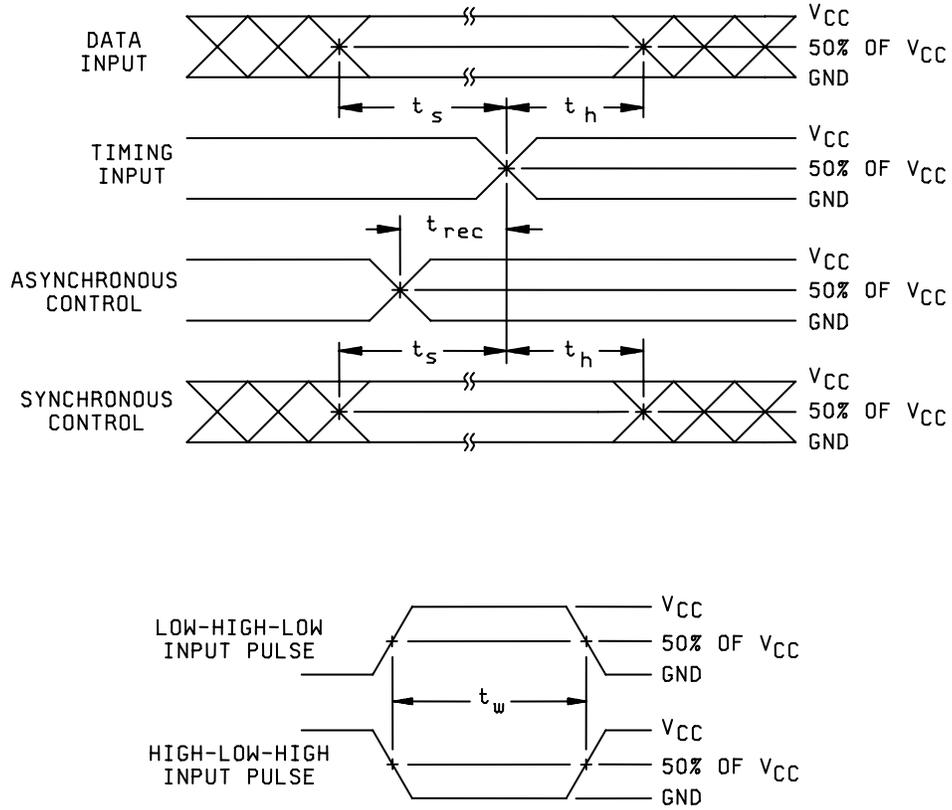


FIGURE 3. Switching time waveforms and test circuits – Continued.

## 4. VERIFICATION

4.1 Sampling and inspection. Sampling and inspection procedures shall be in accordance with MIL-PRF-38535 or as modified in the device manufacturer's Quality Management (QM) plan. The modification in the QM plan shall not affect the form, fit, or function as described herein.

4.1.1 Burn-in and life test circuits. Burn-in and life test circuits shall be constructed so that the devices are stressed at the maximum operating conditions stated in 4.2c or 4.2d, as applicable, or equivalent as approved by the qualifying activity.

4.2 Screening. Screening shall be in accordance with MIL-PRF-38535 and shall be conducted on all devices prior to qualification and conformance inspection. The following additional criteria shall apply:

- a. The burn-in test duration, test condition, and test temperature, or approved alternatives shall be as specified in the device manufacturer's QM plan in accordance with MIL-PRF-38535. The burn-in test circuit shall be maintained under document control by the device manufacturer's Technology Review Board (TRB) in accordance with MIL-PRF-38535 and shall be made available to the acquiring or preparing activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in method 1015 of MIL-STD-883.
- b. Delete the sequence specified as interim (pre-burn-in) electrical parameters through interim (post-burn-in) electrical parameters of table IA of MIL-PRF-38535 and substitute lines 1 through 7 of table II herein.
- c. Unless otherwise specified in the manufacturer's QM plan for static burn-in, test condition A, method 1015 of MIL-STD-883, the test duration for each static test shall be 24 hours minimum for class S devices and in accordance with table I of method 1015 for class B devices.
  - (1) For static burn-in I, all pins except  $V_{CC}$ , Q0, and Q7 shall be connected to GND. Outputs Q0 and Q7 may be open or connected to  $V_{CC}/2 \pm 0.5$  V. Resistors R1 are only required on outputs connected to  $V_{CC}/2 \pm 0.5$  V.  $R1 = 220\Omega$  to 47 k $\Omega$ .
  - (2) For static burn-in II, all pins except GND, Q0, and Q7 shall be connected to  $V_{CC}$ . The GND pin shall be connected to GND. Outputs Q0 and Q7 may be open or connected to  $V_{CC}/2 \pm 0.5$  V. Resistors R1 are only required on outputs connected to  $V_{CC}/2 \pm 0.5$  V.  $R1 = 220\Omega$  to 47 k $\Omega$ .
  - (3)  $V_{CC} = 5.5$  V  $\pm 0.5$  V.
- d. Unless otherwise specified in the manufacturer's QM plan for dynamic burn-in, test condition D, method 1015 of MIL-STD-883, the following shall apply:
  - (1) Input resistors =  $220\Omega$  to 2 k $\Omega$   $\pm 20$  percent.
  - (2) Output resistors =  $220\Omega$   $\pm 20$  percent.
  - (3)  $V_{CC} = 5.5$  V  $\pm 0.5$  V.
  - (4)  $V_{CC}$  nominal =  $V_{CC}/2 \pm 0.5$  V.
  - (5) The  $\overline{OE1}$ ,  $\overline{OE2}$ , and S1 inputs shall be connected to the resistors in parallel to GND. The S0,  $\overline{MR}$  and DS7 inputs shall be connected to the resistors in parallel to  $V_{CC}$ . The I/O0 through I/O7, Q0 and Q7 outputs shall be connected to the resistors in parallel with  $V_{CC}$  nominal. The CP and DS0 inputs shall be connected to CP1 and CP2, respectively.
  - (6) CP1 = 50 kHz to 150 kHz square wave; CP2 = 25 kHz to 75 kHz square wave; duty cycle = 50 percent  $\pm 15$  percent;  $V_{IH} = 4.5$  V to  $V_{CC}$ ;  $V_{IL} = 0$  V  $\pm 0.5$  V;  $t_r$ ,  $t_f \leq 100$  ns.

- e. Interim and final electrical test parameters shall be as specified in table II.
- f. For class S devices, post dynamic burn-in, or class B devices, post static burn-in, electrical parameter measurements may, at the manufacturer's option, be performed separately or included in the final electrical parameter requirements.

#### 4.2.1 Percent defective allowable (PDA).

- a. The PDA for class S devices shall be 5 percent for static burn-in and 5 percent for dynamic burn-in, based on the exact number of devices submitted to each separate burn-in.
- b. Static burn-in I and II failures shall be cumulative for determining the PDA.
- c. The PDA for class B devices shall be in accordance with MIL-PRF-38535 for static burn-in. Dynamic burn-in is not required.
- d. Those devices whose measured characteristics, after burn-in, exceed the specified delta ( $\Delta$ ) limits or electrical parameter limits specified in table I, subgroup 1, are defective and shall be removed from the lot. The verified number of failed devices times 100 divided by the total number of devices in the lot initially submitted to burn-in shall be used to determine the percent defective for the lot and the lot shall be accepted or rejected based on the specified PDA.

#### 4.3 Qualification inspection. Qualification inspection shall be in accordance with MIL-PRF-38535.

4.4 Technology Conformance inspection (TCI). Technology conformance inspection shall be in accordance with MIL-PRF-38535 and herein for groups A, B, C, D, and E inspections (see 4.4.1 through 4.4.5).

#### 4.4.1 Group A inspection. Group A inspection shall be in accordance with table III of MIL-PRF-38535 and as follows:

- a. Tests shall be performed in accordance with table II herein.
- b. O/V and O/I (latch-up) tests shall be measured only for initial qualification and after process or design changes which may affect the performance of the device. Latch-up test shall be considered destructive. Test all applicable pins on 5 devices with no failures.
- c.  $C_{I/O}$ ,  $C_{IN}$ , and  $C_{PD}$  shall be measured only for initial qualification and after process or design changes that may affect capacitance.  $C_{I/O}$  and  $C_{IN}$  shall be measured between the designated terminal and GND at a frequency of 1 MHz.  $C_{PD}$  shall be tested in accordance with the latest revision of JEDEC Standard No. 20 and table I herein. For  $C_{I/O}$ ,  $C_{IN}$ , and  $C_{PD}$ , test all applicable pins on five devices with zero failures.
- d. Subgroups 9 and 11 shall be measured only for initial qualification and after process or design changes which may affect dynamic performance.
- e. Subgroups 7 and 8 tests shall be sufficient to verify the truth table.
- f.  $f_{MAX}$  shall be measured only for initial qualification and after process or design changes which may affect the device frequency. Test all applicable pins on 22 devices with zero failures.

#### 4.4.2 Group B inspection. Group B inspection shall be in accordance with table II of MIL-PRF-38535.

#### 4.4.3 Group C inspection. Group C inspection shall be in accordance with table IV of MIL-PRF-38535 and as follows:

- a. End-point electrical parameters shall be as specified in table II herein. Delta limits shall apply only to subgroup 1 of group C inspection and shall consist of tests specified in table III herein.
- b. The steady-state life test duration, test condition, and test temperature, or approved alternatives shall be as specified in the device manufacturer's QM plan in accordance with MIL-PRF-38535. The burn-in test circuit shall be maintained under document control by the device manufacturer's Technology Review Board (TRB) in accordance with MIL-PRF-38535 and shall be made available to the acquiring or preparing activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1005 of MIL-STD-883.

TABLE II. Burn-in and electrical test requirements.

Line no.	MIL-PRF-38535 test requirements	Class S device <sup>1/</sup>			Class B device <sup>1/</sup>		
		Reference paragraph	Table I subgroups <sup>2/</sup>	Table III delta limits <sup>3/</sup>	Reference paragraph	Table I subgroups <sup>2/</sup>	Table III delta limits <sup>3/</sup>
1	Interim electrical parameters		1			1	
2	Static burn-in I (method 1015)	4.2c 4.5.2	Req'd <sup>5/</sup>			Not req'd	
3	Same as line 1		1	Δ			
4	Static burn-in II (method 1015)	4.2c 4.5.2	Req'd <sup>5/</sup>		4.2c 4.5.2	<sup>4/</sup>	
5	Same as line 1	4.2e	1*	Δ	4.2e	1*	Δ
6	Dynamic burn-in (method 1015)	4.2d 4.5.2	Req'd <sup>5/</sup>			Not req'd	
7	Same as line 1	4.2e	1	Δ			
8	Final electrical parameters		1*, 2, 7*, 9			1*, 2, 7, 9 <sup>4/</sup>	
9	Group A test requirements	4.4.1	1, 2, 3, 4, 7, 8, 9, 10, 11		4.4.1	1, 2, 3, 4, 7, 8, 9, 10, 11	
10	Group B test when using the method 5005 QCI option	4.4.2	1, 2, 3, 7, 8, 9, 10, 11	Δ			
11	Group C end-point electrical parameters				4.4.3	1, 2	Δ
12	Group D end-point electrical parameters	4.4.4	1, 2, 3		4.4.4	1, 2	
13	Group E end-point electrical parameters	4.4.5	1, 7, 9		4.4.5	1, 7, 9	

<sup>1/</sup> Blank spaces indicate tests are not applicable.

<sup>2/</sup> \* indicates PDA applies to subgroups 1 and/or 7, as applicable (see 4.2.1).

<sup>3/</sup> Δ indicates delta limits and shall be required only on table I, subgroup 1, where specified, and the delta values shall be computed with reference to the previous interim electrical parameters (line 1).

<sup>4/</sup> The device manufacturer may, at his option, either complete subgroup 1 electrical parameter measurements, including delta measurements, within 96 hours after burn-in completion (removal of bias) or may complete subgroup 1 electrical measurements without delta measurements within 24 hours after burn-in completion (removal of bias). When the manufacturer elects to perform the subgroup 1 electrical parameter measurements without delta measurements, there is no requirement to perform the pre-burn-in electrical tests (first interim electrical parameter tests in table II).

<sup>5/</sup> On all class S lots, the device manufacturer shall maintain read-and-record data (as a minimum on disk) for burn-in electrical parameters (group A, subgroup 1), in accordance with method 5004 of MIL-STD-883. For preburn-in and interim electrical parameters, the read-and-record requirements are for delta measurements only.

TABLE III. Delta limits at 25°C.

Parameter <sup>1/</sup>	Device types	Limits
I <sub>CC</sub> , I <sub>CCH</sub> , I <sub>CCL</sub>	All	±100 nA

<sup>1/</sup> The above parameters shall be recorded before and after the required burn-in and life tests to determine delta ( $\Delta$ ).

4.4.4 Group D inspection. Group D inspection shall be in accordance with table V of MIL-PRF-38535. End-point electrical parameters shall be as specified in table II herein.

4.4.5 Group E inspection. Group E inspection is required only for parts intended to be marked as radiation hardness assured (see 3.7 herein). RHA levels for device classes B and S shall be as specified in MIL-PRF-38535.

- a. End-point electrical parameters shall be as specified in table II herein.
- b. For device classes B and S, subgroups 1 and 2 in table V, method 5005 of MIL-STD-883 shall be tested as appropriate for device construction.
- c. RHA tests for device classes B and S for levels M, D, P, L, and R shall be performed through each level to determine at what levels the devices meet the RHA requirements. These RHA tests shall be performed for initial qualification and after design or process changes which may affect the RHA performance of the device.
- d. Prior to irradiation, each selected sample shall be assembled in its qualified package. It shall pass the specified group A electrical parameters in table I for subgroups specified in table II herein.
- e. For device classes B and S, the devices shall be subjected to radiation hardness assurance tests as specified in MIL-PRF-38535 for the RHA level being tested. All device classes must meet the postirradiation end-point electrical parameter limits as defined in table I at  $T_A = +25^\circ\text{C} \pm 5^\circ\text{C}$ , after exposure, to the subgroups specified in table II herein.

4.4.5.1 Total dose irradiation testing. Total dose irradiation testing shall be performed in accordance with MIL-STD-883, method 1019, condition A, and as specified herein. Prior to and during total dose irradiation characterization and testing, the devices for characterization shall be biased so that 50 percent are at inputs high and 50 percent are at inputs low, and the devices for testing shall be biased to the worst case condition established during characterization. Devices shall be biased as follows:

- a. Input tested high,  $V_{CC} = 5.5 \text{ V dc} + 5\%$ ,  $R_{CC} = 10\Omega \pm 20\%$ ,  $V_{IN} = 5.0 \text{ V dc} + 5\%$ ,  $R_{IN} = 1 \text{ k}\Omega \pm 20\%$ , and all outputs are open. The output enable control pin(s) shall be connected to  $R_{IN}$  in parallel to  $V_{CC}$  or GND, as applicable, to enable the outputs.
- b. Inputs tested low,  $V_{CC} = 5.5 \text{ V dc} + 5\%$ ,  $R_{CC} = 10\Omega \pm 20\%$ ,  $V_{IN} = 0.0 \text{ V dc}$ ,  $R_{IN} = 1 \text{ k}\Omega \pm 20\%$ , and all outputs are open. The output enable control pin(s) shall be connected to  $R_{IN}$  in parallel to  $V_{CC}$  or GND, as applicable, to enable the outputs.

4.4.5.1.1 Accelerated aging test. Accelerated aging test shall be performed on class B and S devices requiring an RHA level greater than 5k rads (Si). The post-anneal end-point electrical parameter limits shall be as specified in table I herein and shall be the preirradiation end-point electrical parameter limit at  $+25^\circ\text{C} \pm 5^\circ\text{C}$ . Testing shall be performed at initial qualification and after any design or process changes which may affect the RHA response of the device.

4.5 Methods of inspection. Methods of inspection shall be specified and as follows:

4.5.1 Voltage and current. Unless otherwise specified, all voltages given are referenced to the microcircuit GND terminal. Currents given are conventional current and positive when flowing into the referenced terminal.

4.5.2 Burn-in and life test cool down procedures. When the burn-in and life tests are completed and prior to removal of bias voltages, the devices under test (DUT) shall be cooled to within 10°C of their power stable condition at room temperature; then, electrical parameter end-point measurements shall be performed.

4.5.3 Quiescent supply current. When performing quiescent supply current measurements ( $I_{CC}$ ), the meter shall be placed so that all currents flow through the meter.

## 5. PACKAGING

5.1 Packaging. For acquisition purposes, the packaging requirements shall be as specified in the contract or order (see 6.2). When packaging of materiel is to be performed by DoD or in-house contractor personnel, these personnel need to contact the responsible packaging activity to ascertain packaging requirements. Packaging requirements are maintained by the Inventory Control Point's packaging activity within the Military Service or Defense Agency, or within the military service's system commands. Packaging data retrieval is available from the managing Military Department's or Defense Agency's automated packaging files, CD-ROM products, or by contacting the responsible packaging activity.

## 6. NOTES

(This section contains information of a general or explanatory nature that may be helpful, but is not mandatory.)

6.1 Intended use. Microcircuits conforming to this specification are intended for original equipment design application and logistic support of existing equipment.

6.2 Acquisition requirements. Acquisition documents should specify the following:

- a. Title, number, and date of the specification.
- b. PIN and compliance identifier, if applicable (see 1.2).
- c. Requirements for delivery of one copy of the conformance inspection data pertinent to the device inspection lot to be supplied with each shipment by the device manufacturer, if applicable.
- d. Requirements for certificate of compliance, if applicable.
- e. Requirements for notification of change of product or process to contracting activity in addition to notification to the qualifying activity, if applicable.
- f. Requirements for failure analysis (including required test condition of method 5003 of MIL-STD-883), corrective action and reporting of results, if applicable.
- g. Requirements for product assurance and radiation hardness assurance options.
- h. Requirements for special carriers, lead lengths, or lead forming, if applicable. These requirements should not affect the PIN. Unless otherwise specified, these requirements will not apply to direct purchase by or direct shipment to the Government.
- i. Requirements for "JAN" marking.
- j. Packaging requirements (see 5.1).

6.3 Superseding information. The requirements of MIL-M-38510 have been superseded to take advantage of the available Qualified Manufacturer Listing (QML) system provided by MIL-PRF-38535. Previous references to MIL-M-38510 in this document have been replaced by appropriate references to MIL-PRF-38535. All technical requirements now consist of this specification and MIL-PRF-38535. The MIL-M-38510 specification sheet number and PIN have been retained to avoid adversely impacting existing government logistics systems and contractors parts lists.

6.4 Qualification. With respect to products requiring qualification, awards will be made only for products which are, at the time of award of contract, qualified for inclusion in Qualified Manufacturers List QML-38535 whether or not such products have actually been so listed by that date. The attention of the contractors is called to these requirements, and manufacturers are urged to arrange to have the products that they propose to offer to the Federal Government tested for qualification in order that they may be eligible to be awarded contracts or purchase orders for the products covered by this specification. Information pertaining to qualification of products may be obtained from DSCC-VQ, P.O. Box 3990, Columbus, Ohio 43218-3990.

6.5 Abbreviations, symbols, and definitions. The abbreviations, symbols, and definitions used herein are defined in MIL-PRF-38535, MIL-HDBK-1331, and as follows:

GND .....	Ground zero voltage potential
O/V .....	Latch-up over-voltage
O/I .....	Latch-up over-current
I <sub>CC</sub> .....	Quiescent supply current
I <sub>IL</sub> .....	Input current low
I <sub>IH</sub> .....	Input current high
T <sub>C</sub> .....	Case temperature
T <sub>A</sub> .....	Ambient temperature
V <sub>CC</sub> .....	Positive supply voltage
C <sub>IN</sub> .....	Input terminal-to-GND capacitance
C <sub>I/O</sub> .....	Input/output terminal-to-GND capacitance
C <sub>PD</sub> .....	Power dissipation capacitance
V <sub>IC</sub> .....	Input clamp voltage
t <sub>w</sub> .....	Trigger duration (width)

6.6 Logistic support. Lead materials and finishes (see 3.4) are interchangeable. Unless otherwise specified, microcircuits acquired for Government logistic support will be acquired to device class S for National Aeronautics and Space Administration or class B for Department of Defense (see 1.2.2), lead material and finish A (see 3.4). Longer length leads and lead forming should not affect the part number.

6.7 Data reporting. When specified in the purchase order or contract, a copy of the following data, as applicable, will be supplied.

- a. Attributes data for all screening tests (see 4.2) and variables data for all static burn-in, dynamic burn-in, RHA tests, and steady-state life tests (see 3.6).
- b. A copy of each radiograph.
- c. The technology conformance inspection (TCI) data (see 4.4).
- d. Parameter distribution data on parameters evaluated during burn-in (see 3.6).
- e. Final electrical parameters data (see 4.2e).
- f. RHA delta limits.

6.8 Substitutability. The cross-reference information below is presented for the convenience of users. Microcircuits covered by this specification will functionally replace the listed generic-industry type. Generic-industry microcircuit types may not have equivalent operational performance characteristics across military temperature ranges, post irradiation performance or reliability factors equivalent to MIL-M-38510 device types and may have slight physical variations in relation to case size. The presence of this information should not be deemed as permitting substitution of generic-industry types for MIL-M-38510 types or as a waiver of any of the provisions of MIL-PRF-38535.

Military device type	Generic-industry type
* 01	54AC164
* 02	54AC165
* 03	54AC166
* 04	54AC194
* 05	54AC195
06	54AC299
* 07	54AC595

\* To be included at a later date.

6.9 Changes from previous issue. Marginal notations are not used in this revision to identify changes with respect to the previous issue due to the extent of the changes.

Custodians:  
 Army - CR  
 Navy - EC  
 Air Force - 11  
 DLA - CC

Preparing activity:  
 DLA - CC  
 (Project 5962-2090)

Review activities:  
 Army - MI, SM  
 Navy - AS, CG, MC, SH, TD  
 Air Force - 03, 19, 99

NOTE: The activities listed above were interested in this document as of the date of this document. Since organizations and responsibilities can change, you should verify the currency of the information above using ASSIST Online database at <http://assist.daps.dla.mil>.